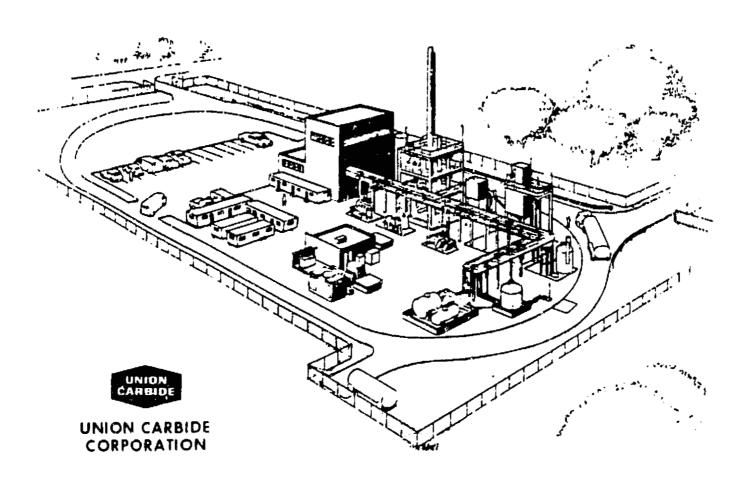
QUARTERLY PROGRESS REPORT

Flat-plate Solar-Array Project EXPERIMENT PRODUCING

JULY - SEPT. 1981

EXPERIMENTAL PROCESS SYSTEM DEVELOPMENT UNIT FOR PRODUCING SEMICONDUCTOR-GRADE SILICON USING THE SILANE-TO-SILICON PROCESS



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ABSTRACT

This report covers work performed in July, August and September, 1981 on the DOE/JPL Contract 954334, Phase III. This phase consists of the engineering design, fabrication, assembly, operation, economic analysis, and process support R&D for an Experimental Process System Development Unit (EPSDU).

Union Carbide has entered into negotiation with DOE/JPL to cost share in the EPSDU program by continuing with construction and start-up with company funds. This has been necessary due to severe government budget recisions in the solar and other energy related programs. As a consequence of such a plan, UCC will relocate the EPSDU facility to a West Coast location to complete and run the facility.

The design activity is complete and mechanical and electrical bid packages will be reissued to obtain bids at the new EPSDU location. About 95% of purchased equipment has been received and will be reshipped to the West Coast location.

The report generation part of the Data Collection System was completed in this quarter. The draft of the operations manual is about 50% complete and the design of the free-space system is continuing.

In the area of melting/consolidation, Kayex has demonstrated the system using silicon powder transfer, melting and shotting on a psuedocontinuous basis. Experimental activity ceases at the end of the quarter and we mentation of the results and recommendations will be completed in the teach quarter.

A proposal has been submitted to continue the very promising fluid-bed work in the next fiscal year with a relatively small budget. The E^SDU pilot plant will probably be funded by UCC in the next fiscal year pending a favorable agreement to be signed soon between DOE/JPL and Union Carbide.

SECTION I. INTRODUCTION

This report covers work performed in July, August and September 1981 on JPL/DOE Contract 954334, Phase III.

The overall objective of the LSA Silicon Material Task is to establish a chemical process for producing silicon at a rate and cost commensurate with the production goals of the LSA project for solar-cell modules. This material must be suitable for utilization in the large-area sheet process and in the automated process for the fabrication of solar cells having satisfactory physical and electrical performance characteristics.

As part of the overall Silicon Material Task, Union Carbide developed the silane-silicon process and advanced the technology to the point where it has a definite potential for providing high-purity polysilicon on a commercial scale at a price of \$14/kg by 1986 (1980 dollars). This work, completed under Phases I and II of the contract, provided a firm base for the Phase II Program (initiated in April 1979) aimed at establishing the practicality of the process by pursuing the following specific objectives:

- Design, fabricate, install, and operate an Experimental Process System Development Unit (EPSDU) sized for 100 MT/Yr to obtain extensive performance data to establish the data base for the design of commercial facilities.
- Perform supporting research and development to provide an information base usable for the EPSDU and for technological design and economic analysis for potential scale-up of the process.
- Perform iterative economic analyses of the estimated product cost for the production of semiconductor-grade silicon in a facility capable of producing 1000 MT/Yr.

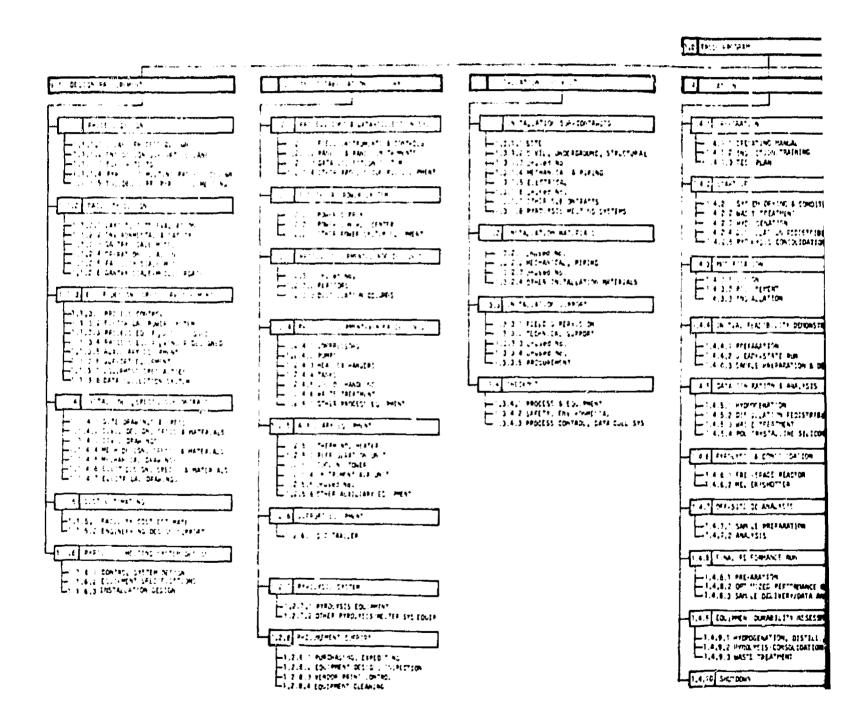
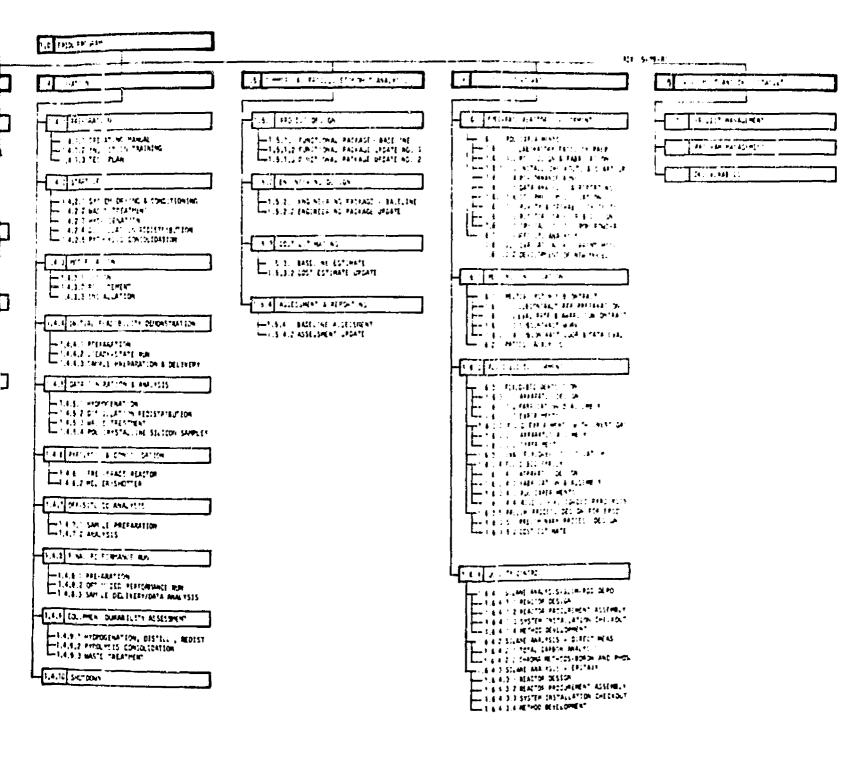


TABLE I
WORK BREAKDOWN STRUCTURE
REVISED FOR FY81, 82, & 83



This process for preparing semiconductor-grade silicon in the EPSDU from metallurgical-grade (M-G) silicon is based on a well-integrated arrangement of purification steps that provides a cost-effective process system.

The three basic steps entail converting M-G silicon to trichlorosilane, redistributing the trichlorosilane to produce silane, and thermally decomposing the silane to form silicon powder. The powder is then melted and the molten silicon is cast into polycrystalline silicon for subsequent use in fabricating solar cells.

The technical progress presented in this report is arranged according to the work Breakdown Structure (WBS) shown in Table I.

SECTION II. TECHNICAL ACTIVITIES (BY WBS NUMBER)

EPSDU PROGRAM

As illustrated in Table I, the current Phase III Program consists of seven primary (WBS level 2) divisions of effort:

- EPSDU Design and Procurement
- EPSDU Equipment Fabrication and Delivery
- EPSDU Installation and Checkout
- EPSDU Operation
- Commercial (1000 MT/Yr) Process Economic Analysis
- Process R&D to Support EPSDU Design and Commercial Analysis
- Program Management

Collectively, these activities encompass all efforts required to attain the program objectives. The subjivisions (WBS levels 3, 4, and 5) define the individual work items that must be performed. The progress for this quarter, documented in this section, is reported at the work-item level.

1.1 EPSDU DESIGN/PROCUREMENT

This effort includes all engineering, design, and procurement activities necessary to transform the process design, developed during the Phase II Program, into a complete installation-drawing package for EFSDU. The major tasks include process design updates, facility design, equipment design and procurement, installation design, and cost estimating support.

1.1.1 Process Design

The process design effort is geared toward using the most recent information available to provide the most practicable integration of process subsystems for attaining the EPSDU Program objectives. The process design package consists of a heat/mass balance, process description, process flow diagram, and functional specifications for process equipment. The original

package, issued in June 1979, served as the basis for the subsequent engineering effort. Beneficial data from the supporting R&D effort and other process-related analyses and experiments were used to update the original package. Process engineers, using information available from the Phase I and Phase II Programs, provide direct support to the facility and equipment design efforts.

1.1.1.2 Engineering Design Support

This activity is complete except for some minor engineering details. An internal meeting will be held in October to assure that all items have been addressed.

1.1.2 Facility Design

The Gantry scale model has been completed and shipped. Work on the facility scale model has been discontinued since the EPSDU layout at the new site will be rearranged.

1.1.3 Equipmest Design, Specification, Procurement

The equipment related effort includes development of the control system, preparation of the piping and instrumentation diagram, preparation of wiring schematics and control panel drawings, and the design of equipment. The specification activity includes definition of specific requirements for each item of equipment, preparation of bid packages, evaluation of vendor quotation, and preparation of final specifications and drawings. Procurement includes the issuance of procurement packages to selected vendors and obtaining comprehensive design information necessary for preparing installation drawings.

The design and procurement of each item of equipment is accomplished through the combined efforts of process engineers, equipment engineers, and purchasing agents. These efforts produce a series of documents that evolve, ultimately, into a complete, definitive procurement package. The individual

documents are as follows:

- Functional Specification
- Engineering Specifications
- Request For Quotation (RFQ)
- Request For Requisition (RFR)
- Purchase Order (PO)
- Procurement Status Report

These six documents serve as milestones for measuring performance of the procurement cycle for each item of equipment.

1.1.3.1 Process Control

The final review schematic wiring diagram and the primary recommended spare parts list were issued. The preliminary programming of the Modicon Programmable Controller was completed in September.

1.1.3.7 Other Equipment, Specialties

The cleaning of speciality items (valves, etc) to meet the cleaning specifications is approximately 80% complete and will be completed in October. The Pyrolysis Hydrogen Compressor refitting will also be completed in October.

1.1.3.8 Data Collection System

A description of the Data Collection System for the 100 MT/Yr silane-to-silicon EPSDU was issued. The Archive System was completed, but documentation remains to be written.

1.1.4 Installation Design, Specification, Subcontract

This design effort includes development of separate installation drawing packages for the site, civil, mechanical, and electrical specialties based on the engineering design effort and vendor-supplied information. Specification activity includes definition of specific requirements for performing all installation functions. Subcontracting includes the preparation of bid packages, evaluation of quotes, sub-contractor selection and contract negotiation.

1.1.4.4 Mechanical Design, Specification & Materials and

1.1.4.5 Mechanical Drawings

Final drawings and specification changes were completed and the mechanical installation package was marked "For Construction/Hold." The potential contractors were notified that contracts would not be awarded at East Chicago.

1.1.4.6 Electrical Design, Specification & Materials and

1.1.4.7 Electrical Drawings

The bids for the EPSDU electrical work were received and evaluated. A contract was not awarded since the EPSDU pilot facility will be relocated in Washington state. Final drawing and specification changes were completed and the electrical installation package was marked "For Construction/Hold."

1.1.6 Pyrolysis/Melting System Design

The Free-Space Reactor/Powder Hopper design previously developed was reviewed and design modifications were made to improve the design.

Modifications include:

- Safety valve was replaced with a hurst disc.
- Vacuum line was relocated to prevent plunging.
- Powder transfer line was respecified to use polished stainless steel tubing.
- Agitator was relocated and supports redesigned.
- Powder level detectors were added to the silicon powder/ hopper design.
- Seal for quartz liner was modified to a metal bellows type.

Fabrication drawings for the free-space reactor were completed.

Design work has begun on the hopper vessel which feeds silicon powder to the melter unit. A preliminary lay-out was completed for the steel structure

which supports the free-space reactor/hopper, silicon powder melter/shotter and shotter fluid bed system. Detailed structural drawings are currently under preparation.

1.1.6.1 Control System Design

Preliminary P&I diagrams have been developed for both the free-space reactor and the shotter/melter. The shotter/melter includes the silicon powder melter, shotter and a fluid bed shot collection unit located below the shotter tower.

1.2 EQUIPMENT FABRICATION/DELIVERY

This report item includes all in-house and outside activities associated with fabrication, delivery, and vendor coordination for all items of equipment.

1.2.1 Process Control and Data Collection System and

1.2.2 Electrical Power System

A summary table of purchased items is as follows:

W.B.S. No.	Description	Purchase Orders	Number Of Items	Cost (\$,000)
1.2.1.1	Field Instruments and Controls	€2	€32	166
1.2.1.2	Panels and Fanel Instruments	59	462	163
1.2.1.3	Data Collection System	19	150	165
1.2.1.4	Other Process Control Equipment	11	66	51

1.2.2.1	Power Supply	1	1	20
1.2.2.2	Power Control Center	1	2	54
1.2.2.3	Other Jower System Equipment	1	1	35

1.2.3 Process Equipment--Linde Designed

This task includes the effort required for the fabrication, delivery, and acceptance of the free-space reactor with hopper, hydrogenation and redistribution reactors, distillation columns, and other process equipment.

A summary table of purchased items follows:

W.B.S. No.	Description	Orders	"umber Of Items	Cost (\$,000)
1.2.3.2	Reactors (Vendors Supp	2	7	139
1.2.3.3	Distillation Columns	ε	4	225

1.2.4 Process Equipment -- Vendor Designed

This task includes the effort required for the fabrication, delivery, and acceptance of compressors, pumps, heat exchangers, tanks, solids handling equipment, waste treatment equipment, and other process equipment.

A summary table of purchased items follows:

W.B.S No.	Description	Purchase Crders	Number Of Items	Cost (\$,000)
1.2.4.1	Compressors	4	5	163
1.2.4.2	Pumps	8	14	54
1.2.4.3	Heat Exchangers	8	14	73
1.2.4.4	Tanks	8	22	181
1.2.4.5	Solids Handling	7	8	24
1.2.4.6	Waste Treatment	3	7	51
1.2.4.7	Other Process Equipment	3	4	67

1.2.5 Auxiliary Equipment

This task includes the efforts required for the fabrication, delivery, and acceptance of the therminol heater, refrigeration unit, hydrogen and argon storage tank, and other auxiliary equipment.

A surmary table of purchased items follows:

W.B.S. No.	Description	Purchase Orders	Number Of Items	(000,2) tac2
1.2.5.1	Therminol heaters	1	1	46
1.2.5.2	Refrigeration Unit	1	1	92
1.2.5.3	Cooling Tower	1	1	10
1.2.5.4	Instrument Air	2	2	30
1.2.5.6	Other Auxiliary	26	1663	33

1.2.6 Support Equipment

These items are associated with the fitting-out of the Quality Control (Q.C.) Trailer. The trailer has been delivered to the site at East Chicago, however, laboratory equipment has not yet been received and will not be installed until it is transferred to the Washington site.

1.2.8 Procurement Support

This task includes the Procurement Department effort necessary to initiate, monitor and control the purchase of equipment. It also includes work associated with cleaning specialty items to strict standards, since the component suppliers cannot meet the specifications.

1.2.8.1 Purchasing, Expediting

Equipment items received at the East Chicago site are being checked and tagged. The updated procurement status report is shown as Appendix A. Approximately 92 percent of the items charged to 1.2 have been received and invoices paid.

1.2.8.4 Tonawanda Equipment Cleaning

Cleaning of specialty items is about 80% complete, this activity will be completed in October. The specialty items consist of valves, instruments, transmitters, flowmeters, etc.--564 items will be cleaned to meet the chlorosilane specification, and an additional 147 items will be cleaned to meet electronic grade quality.

1.4 OPERATION

1.4.1 Preparation

1.4.1.1 Operations, Operating Manual

Volume I of the operating manual has been put on the word processor system. This volume contains two sections—the first section deals with chemical safety and gives detailed description of the handling of all chemicals which are involved in the process. The second section addresses plant safety procedures and describes in a manual form the operation requlations for safe operation of a plant. The draft is receiving an initial review by Safety Personnel at Tonawanda and Sistersville, but must be reviewed again before plant start—up to assure that all possible hazards for a silane plant have been considered. Volume II (description of the process) and Volume III (operation) are currently being written.

1.4.1.3 Operations, Field Inspection and Calibration

The equipment at East Chicago has been prepared for transfer to the new site--the gantry has been disassembled and loaded on two trucks. Large vessels are being put on cradles and smaller items are being repackaged. The transfer will be completed in October. The Q.C. trailer has been delivered to East Chicago site but will be transferred to the West Coast.

1.6 PROCESS SUPPORT R & D

The supporting R & D Program is separate from the mainstream design effort and includes all activities associated with analytical and experimental development of the free-space reactor, melting/consolidation system, fluid-bed reactor system, and quality control techniques and procedures. Information generated in this program will be used for the EPSDU effort and the commercial facility economic analysis.

1.6.2 Melting/Consolidation

The design and development effort necessary to obtain a reliable melter for EPSCU involves UCC and sub-contractor (Kayex) effort.

1.6.2.1 Melter System Subcontract

This effort involves establishing and managing the sub-contract and sub-contractor development, design, and fabrication efforts.

Kayex Corporation is developing the silicon melter system for EPSDU. The silicon consolidation scheme is based on melting the powder in a quartz crucible and dropping silicon shot from the crucible bottom into a cooling tower where the shot is solidified. The goal is to design and build a melting/consolidating system suitable for installation in the EPSDU.

During the third quarter, the sub-contractor has completed the final experimental runs to demonstrate feasability, the final report writing and documentation will take place in October.

During the period from June through August 1981, 10 melt runs were made. The pertinent details of each run are listed:

• Melt Run Number 10 (6/3): Purpose - to produce shot using a 0.55 mm orifice in a capillary tubing nozzle with 3 21 kg of silicon chunks. Results - shotting was maintained for 35 minutes as a throughput of 2.42 kg of silicon (76% of load) was obtained. Orifice erosion was 15.5% per hour. Excellent shot was produced with an optimum downward applied pressure difference of 2.0 psi.

- Melt Run Number 11 (6/19): Purpose to produce shot using a 0.66 mm orifice after melting 1.38 kg of silicon chunks and feeding and melting silicon powder. Results the ball valve between the auger and the furnace tank jammed with powder, so only the chunks were melted and shotted. Nearly 100% throughput was achieved in 15 minutes of shotting. Orifice erosion was 16% per hour.
- Melt Run Number 12 (6/26): Purpose to melt 1.35 kg of silicon chunks, feed and melt powder, and produce shot using a 0.58 mm orifice. Results chunks were melted, powder was fed until it backed up into the quartz powder feeding tube and shot was produced. Powder melted in the quartz tube and blocked further powder flow. The shot stream was non-vertical so that "splat" built up on the drop tube wall, eventually falling and breaking the collection tube.
- Melt Run Number 13 (7/9): Purpose to melt silic n chunks, feed and melt powder and produce shot from a 0.58 mm orifice. Results the chunks were melted, and powder was fed, but a loss of building water pressure caused the generator to shut down, ending the run prematurely.
- Melt Run Number 14 (7/20): Purpose to use the cylindrical tubing coil to melt and shot silicon chunks and to feed, melt and shot silicon powder. Results the coil water stayed cool (<125°F), but power did not exceed 89%, and the chunks could not be melted.
- Melt Run Number 15 (7/22): Purpose to use the cylindrical tubing coil to melt silicon chunks after raising the generator current limit and balancing the three phases. Results power reached 104%, but the silicon could not be melted.
- Melt Run Number 16 (7/27): Purpose to melt and shot silicon chunks and to feed, melt and shot silicon powder using the rectangular tubing coil with a water booster pump in the coil water line which increased coil water flow significantly. A 0.56 mm orifice and 1.15 kg of chunks were used. Results the coil water stayed cool (<130°F), the chunks were melted, powder was fed and melted and shotting began, but the collection system

piping became blocked with shot and the crucible rose out of the susceptor, ending the run.

- Melt Run Number 17 (8/11): Purpose to melt silicon chunks, feed and melt silicon powder and produce shot while using a modified collection system, a load cell readout, automatic temperature control, and a shotting rate sensor. Results the auto temperature control loop and the shot flowrater worked fine, the load cell readout was obscured by changes in pressure difference, and the collection system jammed with shot, forcing termination of the run.
- Melt Run Number 18 (8/18): Purpose to melt silicon chunks and feed and melt silicon powder and produce shot while using headsets to communicate, using the load cell with the ΔP subtracted out, using a modified collection system with the shot going directly into the collection drum (no diverter plate) and using the automatic temperature controller and shot flowrater. Results the headsets greatly aided operator communication, the temperature controller maintained a constant temperature at a given set point and was used throughout the run, the collection system worked without any problems, shotting was maintained for a record 1-3/4 hours and shot was definitely produced from melted powder for the first time. Also arcing occurred on the molybdenum radiation shield, burning holes in it (cause unclear).
- Melt Run Number 19 (8/28): Purpose to melt and shot silicon chunks, then to feed and melt silicon powder and produce shot in order to test if powder-melt shot is inferior to chunk-melt shot. Also to use a reverse flow check valve to prevent a negative ΔP which would cause the crucible to jump out of the susceptor, to use a chart recorder for the temperature readout, to use a full-bore ball valve and plexiclass tube for the powder feeding system, to use a quartz crucible hood with a small (1") viewport hole in it, to use a powder level detector in the upper control mounting chamber, and to use a radiation shield wired to its support tube. Results the temperature readout on the chart recorder occurred over a narrow bank which requires to be widened, the manual powder feed system worked without difficulty, arcing of the radiation shield did not occur and the powder

level detector worked, but it was too sensitive to falling powder. Alsohigh quality shot was obtained from the chunks melt, a powder melt was created with almost no melt in the crucible to start with, and the powder melt shotted without delay (previous powder melt runs had orifice plugging problems), but the quality of the shot was poorer (slower, forming splat) than that of the chunk melt.

Kayex progress reports to UCC are out of phase by one month with the UCC reporting to JPL. During September, Kayex made three successful melt runs and produced a total of approximately 10 kilograms of silicon shot during simultaneous powder feeding, melting and shotting.

1.6.3 Fluid-Bed Development

This development program includes all analytical, experimental, and design effort associated with developing a fluid-bed reactor as an alternative or backup system to the free-space reactor.

The experimental work was stopped in May 1981 due to budget recisions, however, since the fluid-bed concept is potentially very attractive, it is proposed that work will be restarted in the next fiscal year.

1.7 MANAGEMENT AND DELIVERABLES

This report item includes all activities associated with managing the program and insuring that all deliverables are made in accordance with the program requirements.

PIM Meeting

The 18th PIM meeting was held on July 15/16, 1981 in Pasadena. Dr. Morihara made a 45-minute presentation showing EPSDU progress. In his presentation, he showed a collection of colored slides taken at East Chicago during construction and microphotographs of particles taken from the fluid-bed after silane pyrolysis.

Deliverables

The monthly technical progress reports along with the monthly financial and management reports were issued as required by the contract. The second quarter 1981 progress report was also issued during this period. A proposed work plan for continuation of the fluid-bed activity during fiscal year 1982 was delivered to JPL in August.

Major Milestones

The major milestones reached this quarter are presented in Table II.

TABLE II MAJOR MILESTONES REACHED

WBS NO.	MILESTONE	DESCRIPTION OF MAJOR MILESTONE
1.1.2.6	Α	Gantry scale model undate-complete.
1.2.1.1	G	Field instruments and controls-all equin- ment received.
1.2.1.3	J	Data collection system-purchase orders issued.
	G	Data collection system-all equipment received.
1.2.2.2	G	Power Control Center-all equipment received.
	н	Power Control Center-final invoice paid.
1.2.4.3	Н	Heat exchangers-final invoice payment.
1.2.6.1	G	O.C. trailer-all equipment received.
1.2.8.3	G	Vendor print control-all drawings on file.
1.4.1.3	0	Test plan started
1.7.3	U, V, W	Monthly financial and management reports.
	V, W	Monthly technical progress reports.
	G	Quarterly technical progress reports.

SECTION III. CONCLUSIONS

Significant highlights and conclusions are presented according to the relevant WBS numbers.

1.1 DESIGN/PROCUREMENT

1.1.1 Process Design

- This activity was completed except for some minor details.
- A safety review of the pressure relief system remains to be made.

1.1.3 Equipment Design, Specification, Procurement

- Schematic wiring diagram was completed.
- Equipment cleaning is 80" complete.

1.1.4 Installation Design, Specification, Subcontract

 Mechanical and electrical construction subcontracts were not awarded due to lack of funds.

1.1.6 Pyrolysis/Melting System

- Fabrication drawings for the free-space reactor were completed.
- Detailed structural drawings are in preparation.

1.2 EQUIPMENT FABRICATION/DELIVERY

Approximately 95% of equipment has been received.

1.3 INSTALLATION AND CHECKOUT

Equipment is being repackaged for shipment to the new EPSDU site.

1.4 OPERATION

- The draft of Volume I (Chemical and Plant Safety) is under review by UCC Safety Personnel.
- Volumes II (Description) and III (Operation) is being written.

1.6 PROCESS SUPPORT R&D

1.6.2 Melting/Consolidation

• Kayex has completed the experimental program with a total of 22 melt runs and has demonstrated simultaneous powder feeding, melting and shotting. Documentation will occur during the last quarter.

1.6.3 Fluid-Bed Development

 This activity has been placed on hold but may be continued in 1982 fiscal year.

SECTION IV. PROJECTED QUARTERLY ACTIVITIES

1.1 EPSDU DESIGN/PROCUREMENT

1.1.1 Process Design

• The safety review of the pressure relief system design which was scheduled for the third quarter was not held, the review will take place in the fourth quarter.

1.1.3 Equipment Design, Specification, Procurement

- Cleaning of specialty items will be completed.
- Hydrogen compresser will be refitted.

1.1.6 Pyrolysis/Melting System Design

Complete design activity for free-space reactor with available manpower and issue a draft package.

1.2 EQUIPMENT FABRICATION/DELIVERY

- Balance of equipment will be delivered to EPSDU site and invoices paid.
- Equipment cleaning will be completed.

1.3 INSTALLATION & CHECKOUT

• Complete transfer of equipment.

1.4 CPERATION

Complete operations manual.

1.5 COMMERCIAL PROCESS ECONOMIC ANALYSIS

No activity planned.

1.6 PROCESS SUPPORT R&D

1.6.2 <u>Melting/Consolidation</u>

 Edit and issue final report summarizing the experimental contract with Kayex.

1.6.3 Fluid-Bed Development

• Continue fluid-bed experimental work from the point at which it was stopped in May.

1.7 MANAGEMENT AND DELIVERABLES

- Monthly financial and management reports will be issued.
- Monthly technical reports will be issued reporting contractual items.

APPENDIX A

EQUIPMENT PROCUREMENT STATUS

SEPTEMBER 1981

September 30, 1981 EQUIPMENT PROCUREMENT STATUS

BOUIPHENT NO. & MANE	P. O. NUMBER	FUYC SPECS 1\$SUED	ENG SPECS ISSUED	rpq 135uep	rfr Tssued	P.O. ISSVED	GEATIFIED DWG 166'U	EQUIP- MENT EBC'U
463-04-03 Waste Gas Induction Blower	\$0003	,	,	1	•	1		,
453-02 Aggiomeration Blower	50002	,	,	v	1	•	1	~
	\$9003							
	\$04.14					:		
126-12 Oudhch Contieror Lump	5/19/15	•	•	•	*	1	•	-
	50000							
	\$0007							
	\$100S							
	SOMO			-				
423-02, 57 Pervele 1, Compressor	50010	1	,	. 4	1	4	1	1
443-02 Pyrolysis H ₂ Compressor	50011	,	>	•	>	٦	•	•
466-92 Hot Gil Pump	50012	,	•	٠	•	١	*	•
466-04, 05 Cooling Suiter Pump	50013	,	•	•	1	>	1	V
424-92 Ouench Condenser	50014	,	•	1	1	•		,
424-04 434-06, In Reboilers	50015	1	1	•	•	*		. •

		27	المنتفادات	T STATUS				
EQUIPMENT NO. 6 YAME	P. O. NUMBER	FUNC SPECS LSSUED	ENG SPECS ISSUED	RFQ ISSUED	RFR Issued	P.O. Issued	GERTTETEL Defi Rec'u	EQUIP- MENT BEGIO
434-02 Stripper Condenser	\$0 016	•	1	✓	1	1	1	✓
421-12, 15 441-96 Tanks	5: 017	!	1	1	1	1	1	•
464-62, UI Ventilation Heat Exchances	50018							
434-08, 14, 18 Column Condensers	50019	•	✓	•	1	1	✓	,
	50020	!						
	50021							
/34-12, 16, 24 443-32 Coolers	50022	•		1	\	4	1	. ٧
	50023		i					
	30024	• • •						
	5 GP 25	!	! 					
	50026							
	\$3027							
431-26 Refrig. Heating Co.1	50928	1	1	•	~	•		/
	50039							
	50030							

	EC	UIPMENT	PROGUREME	NT STATUS				
EQUIPMENT NO. & NAME	P. O. NUMBER	FUNC SPECS ISSUED	ENG SPEGS 1880ED	rfq 1.55ued	RFR ISSUED	F.V.	CEKTIFIED DWG REC'D	EQUIP- PENT REC'D
	50031	•						
	50032					· · · · · · · · · · · · · · · · · · ·		
411-02, 441-04 461-08 Bins	50033	1	1	1	1	1	•	/
	50034	:						
421-92,04,06,08,10,14,18 431-04,66 Tanks	50035	1	1	,	1	✓	•	,
	50036		1		!			
	50037	,						,
	50038	,	;					
	50039	i						
151-04, 56, 08, 10 435-02, 04 Tank+ 5 kenctors	50040	1	1	1	V	1	-	/
	50041							
	50042							
	50043							
	50044							
	50045							

EQUIPMENT NO. 5 NAME	P. O. NUMBER	FUNC SPECS 155UED	ENG SPECS 188UED	RFQ Issued	AFA ISSUED		CERTIFIED DWG REC'D	EQUIP- MENT REC'D
	50016	1		t ;				
	5004"							
	50018			!				
	50049	 						
	50050	F L						
	50051	i						
	50052	•						
	\$4053	· •						
	50054	į	1					
161-02 hot Oil Expansion Tank	50055	-	•	•	1	V	1	1
425-02 Hydrogenation Reactor	50056	1	1	1	1	4	1	✓
4x5-02 Quart: Liner	50057							
	50053							
445-02 Pyrolysis Reactor and Hopper	50059							
117-02 457-94, 06 Filters	50060	1	•	>	*	~	1	1

EQUIPMENT NO. 6 NAME	P. O. NUMBER	FUNC SPEGS ISSUED	ENG SPEGS ISSUED	RFQ 155UED	RFR 155UED	P.O. ISSUED	Cortified DNG Recid	EQUIP- MENT REC'D
12**02 Crude TCS Filter	\$0041	; /	1	✓	•	~ '	•	/
437-02 Silane Ditro Filter	50062	1	1	1	•	1	V	1
	50063							
	\$0064							
	50005							
	50000	ţ ;	i i					i
445-08, 10 Loading Scales	50067	1	<u>.</u>			77		, , , , , , , , , , , , , , , , , , ,
	50-68	; ;				,		
445-04 Boule Cart	50069	!	1					
448-14 Boule Scale	\$ 00 ~a	1						
	500-1							· · · · · ·
	50072							
458-04 Silica Drum Packer	500~3	1		4	1	1	1	1
	500-4							
وخدار والمساولة			<u> </u>					

EQUIPMENT NO. 6 NAME	P. O. NUMBER	FUNC SPEGS 15SUED	ENG SPEGS 155UED	RFQ 155UED	NFR ISSUED	P.U.	CERTIFIED DWG REC'D	EQUIP- MENT REC'D
459-02, 04 Venturi and Sarupber	50075	1	1	1	1	1	1	/
429-04 Superheater	50076	/	1	1	4	v	1	•
	50077						,	
	500-8							
	50079	1						
	50060							
	50081	,						
	50082							
459-08, 10, 12, 14 Waste Burners	50083	~	1	✓	1	1	1	1
	50084							
454-04 Silica Agglomerator	50085	•	•	1	•	•	•	•
469-02 Cooling Tower	50086	1	1	1	✓	✓	1	~
469-06 Cooling Tower Treatment	50087	1	v	✓	1	\$	1	1
469-12 Refrigeration System	50088	1	1	1	✓	•	1	1

EQUIPMENT NO. & NAME	P. O. MANGER	FUNC SPECS ISSUED	ENG SPECS ISSUED	i RFQ 195UED	RFR 185UED	P.C. ISSUED	CENTIFIED DWG PEC'D	EQUIP MENT REC'D
in9-16 Thorminal Heater	53089	' /	1		~	/	/	-
452-02 Muriatic Tailing Column	50090		•	•	J	1	v	/
150-18 Tailing Column Pump	50091	~	1	y	1	1	•	,
1691 Instrument Air Package	50092	-	· •	1	√	✓	1	1
642-02 MCC	50093	-	1	1	1	/	1	1
(4)-)2 Transformer	50004	-	1	1	1	✓	1	/
	50095							
365-32 Quality Control Trailer	50096	i 🗸	1	1	1	1	1	/
	50097	i i						
411-08 TL Argon Tank	50098							
ie:-94, Ob Fuel Cil Storage Tank	50099	1	1	1	1	1		✓
	50100							
	50101							
643 Emergency Generator	50102	~	1	√	✓	V	•	1

P. O. NUMBER	FUNC SPECS 1 SSUED	ENG SPECS ISSUED	RFQ [SSHED	RFR ISSUED	,,,,,	CERTIFIER DWG REC'D	EQUIP REC'D
\$0103	i		!				
\$0164	1						
50105	1	1	√	v	✓	J.	
50106	!		 	i			····
50107	1	. ✓	1	1	1	1	1
50108		. 1	✓	V	1		
50109	/	✓	V	v	✓		1
30110	1		1	1	1		✓
50111	✓	1	1	✓	✓		1
50112	•	1	1	1	✓		1
50115	•	1	•	1	1		•
50114	1	1	1	v	J		~
50113	1	1	1	4	1	٧	1
50116	1	V	J	7	J	1	1
	\$0103 \$0104 \$0106 \$0106 \$0107 \$0107 \$0110 \$0111 \$0112 \$0113	\$0103 \$0104 \$0105 \$0106 \$0107 \$0107 \$0109 \$0110 \$0111 \$0112 \$0114 \$0114 \$0115	\$0103	\$0103	\$0105 ISSUED ISSUED ISSUED ISSUED	SOUTH SSUED ISSUED ISS	SOURCE ISSUED ISSUED ISSUED ISSUED REC'D

EQUIPMENT NO. 6 NAME	P. O. NUMBER	FUNC SPECS LSSUED	ENG SPECS 15SUED	REQ 155UED	RFR ISSUED	P.O. Issued	IÉRTIFIED DWG DEC'D	EQUIP- MENT RÉC'D
	50117	,						
	50118	ı				"		
4bh- 6, 07 fuel Oil Pumps	30110	✓	1	1	1	✓	1	,
	\$0120							
	50121	!!!!!!!!!!!!!!!!!!!!!!!!!!!!!!!!!!!!!!!						
452-98 Silane Column	50122	; 🗸		1	V	1		1
	50123							
Field Instrumentation	50124	. 🗸		,	v	~		'
469-20 Instrument Air Oryer	50125	' v		~	v	V	v	,
428-04 Solids Conveyor	50126		1	V	v	V	1	/
	50127							
	50128							
464-06 Thaw Heater	50129	~	~	~	✓	V	4	✓
Program Controller	50130	1	,	•	•	U°		
		-				100J-W		· · · · · · · · · · · · · · · · · · ·

EQUIPMENT PROGUREMENT SVATUS											
EQUIPMENT NO. & NAME	P. O. NUMBER	FUNC SPECS 155UED	ENG SPECS ISSUED	RFQ ISSUED	RFR ISSUED	P.O. 185UED	CERTIFIE UNG REC'D	EDIUP HENT BEC D			
7 Hasker Pumps	50131	i 🗸	1	1	_	√					
Pressure Lubricators	50132	1 /	1		\	1		✓			
8 BP Valves & 7 Springs	50133		V	,	/	✓		1			
Main Instrument Panel "A"	50134	· /	,	1	~	-		_			
Printer	50135	: v .	/	,	1	1					
Computer	50136	~	• •	1	v	1		<u> </u>			
Memorex Cartridges	50137	· •		✓	v	. 1					
Automatic Valves	50138	✓	1	ښ	*	1		1			
Automatic Valves	50139			/	1	V		/			
Automatic Valvės	50140	1 1	1	•	/	1		_			
Augomatic Valves	50141	1	•	•	1	✓		~			
Automatic Valves	50142	1	1	•	1	1					
	50143					اد.					
	50144						,	معرد دروس			
7 Gauges	50145	1	1	1	,	1		1			

EQUIPMENT NO. & NAME	P. O. NUMBER	IFUNG ISPECS ISSUED	ENG SPEGS 155UED	RFQ 155UED	RFR ISSUED	P.O. Jasued	CERTIFIEL DWG PEC'D	EQUIP MENT REC'D
Pressure Lubricators	50146	· 🗸	,			1		✓
Thermocouples	50147	-	~	·	/	1		Y
7 Level Switches	50148	/	i •		,	_		
	50149] ; ;	•				
Sewer Tie-In Line	50150		· ,	· •	~	,		
Service Agreement	50151	1	· •		, v	7		
	50152		•			•		
Lever [ransmitters & Switches	50153			,	,	_		✓.
Field Instrumentation	50154		:	/	•	,		4
Conditioners & Process Filters	50155		; ! •	•	,	1		1
sample Conditioners	50156	1	•	•	,	/		
Sample Conditioners	50157	1	~	,	٠,	•		
	50158							
Manual Valves	501 59	v	•	v	v	~		~
Caustic Storage Tank	501/60	1	1	-	,	,	1	~

EQUIPMENT PROGUREMENT STATUS											
EQUIPMENT YO, & NAME	P. O.	FUNC SPECS 1559ED	ENC SPECS 1,55UED	rug Teened	NFA ISSUED	P.O.	GERMETER DAG REC'D	VEC. C			
Immersion Heater	50161		,	!		**	/	~			
Fuel Tank	50162	· /	/	1		,	٧'	•			
Shipping Preparation & Freight	50163	<u> </u> -				,					
Automatic Valve	50164		1	•	/	~		1			
	i 50165	<u>.</u>		!							
Main Instrument Panel "A"	₅₀₁₅₆		1	1	v	~					
Main Instrument Panel "A"	: 50167	~		•	,	٠ ر					
Field Instrumentation	50168	✓		,	_						
Main Instrument Panel "A"	50169			-	1	~					
Main Instrument Panel "A"	50170	·	,	,		v					
·	501 <i>7</i> 1										
Main Instrument Panel "A"	50172	•	1	,	,	/					
Main Instrument Panel "A"	501 73	1		J	J	1					
Main Instrument Panel "A"	50174		,	v	-	•					
Hain Instrument Panel "A"	50175	1	1	-	•	v					

EQUIPMENT NO. 4 NAME	P. O. NUMBER	FUNC ISPECS ISSUED	ENG SPECS 155UED	RFQ 155UED	RFA 155UED	P.O. 155UED	GERTUE IE	EQUIP: PENT REC'D
Main Instrument Panel "A"	50176	! ,	, w	1		1		
Field Instrumentation	50177	,	/	/	-	-		•
Field Instrumentation	50178		-	! <i>/</i>	/	,		,
Field Instrumentation	501 79	/	· .		J	~		/
Field Instrumentation	50180	4		1	,	1		1
Field instrumentation	501.81	1	· •	ď	,	1		/
Field Instrumentation	; 50182	~		•	اً ر			/
Field instrumentation	50123	•		J	•	1		,
Field Instrumentation	50184	•		,	,	•		/
Field Instrumentation	50185	` /	•	,	~	,		/
Valves	50186		•	ں	,	v		1
Filter Bags	50187	,	•	J	•	,	•	1
Valves	50188	1	1	,	1	•		✓
Yal ves	50189	1	1	1	1	1		1
Automatic Valves	50-190	•	,	•	,	•		1

EQUIPMENT PROGUNETERY STATUS										
EQUIPMENT NO. 6 NAME	P. O. NUMBER	FUNC ISPECS ISSUED	ENG Syegs 1550eg	RFQ ISSUED	RER 15,5(5ED)	P.O. ISSUED	CERTAFIE Days REG*D	enuip. Ment Regin		
Automatic Valves	50191	/	,	,	•	•		•		
Automatic Valves	50192				•	•		_		
Automatic Valves	50193	<u>:</u> ,			,			/		
Check Valves	50194	/				•		1		
Field Instrumentation	50195	•			, i	,		v		
	50196									
Figld Instrumentation	50197	V	_		-	• ,		/		
	. 50198		•							
Field Instrumentation	! 50199		_	,	_	,		1		
Field Instrumentation	50200	/	•	~	•	~		1		
Field Instrumentation	50201	•	•	,	v	٧		•		
Controller	50202	•	~	•	~	V		/		
Instrument Field List	50203	J	~	-		1				
Instrument Field List	50204	•	~	~	-			1		
Instrument Field List	50205	•	١	•		~		1		

EQUIPMENT NO. & NAME	P. O. NUMBER	FUNC SPECS ISSUED	ENG SPECS 1.5 SUED	req Issued	AFR 1559EĐ	P.O. 155843	CERTIFIE DAG PEC.D	equid Heat Meat Meat
Manual Valve Packless	50206		,	يل ا		•		•
Rubber Hose	50207			•		•		•
	50208	;	; ;	! !				
Field Instrumentation	50209	٧			·	•		/
Field : strumentation	50210		•	/				<i>•</i>
Field instrumentation	50211	,	/	,	_			,
Field instrumentation	50212	~	! ,	/	•	• •		1
	50213		,					
Field Instrumentation	50214		•	v	_	-		V
Field Instrumentation	50215			¥	J	•		~
Manual Valves "Packless"	50216	-	1	•	7	-		•
Manual Lined But-Valves	50217		•	•	•	•		•
Main Instrument Panel	50218	,		J	_	,		
Panel No. 2 "E"	50219	,	•	>	,	-		/
Panel :10. 1 "D"	50220	-	•	٧	~	-		✓

EQUIPMENT PROGUNEIENT STATUS										
EQUIPMENT NO. (NAME	P. O. NOMEER	PRUNC SPEGS 1,5,50ED	ENG Specs Issued	REQ ISSUED	NUR ISSUESE	P.O. 155UE	CERMINE DIG NESSO			
Panel No. 4 "G"	50321		-							
Panel No. 3 "F"	50222		-	<u>.</u>	•	•		j		
Sample Panel "QA"	50223	-	 	<i>.</i>		_		_		
Raw Valve Packing Pressurization	50224	V		-				1		
Solenoid Valves	50225	•	J							
Teflon-Lined Piping	50226					-		✓		
Sample Conditioners	50227	,	,	J	ار	. ,				
Sample Conditioners	50228		/		,	v				
Fittings	50229			,		,				
48 Packless Valves å 18 Diaphragms	50230		•	,	,	,				
Sample Conditioners	50231		•	•	•	,				
Manual Knife Valve	50232	_	J.	~	J	_		V		
Safety Relief Valves	50233			,	,	v		-		
Safoty Relief Valves	50234	•	v	J	v	•		1		
Vacuum Relief Valves	50235		,	•	•	•		•		

egetpænt ko. (najæ	P. O. STOPPER	FUNE SPEGS ISSUED	ENG SPEGS 155MEG	RFQ ISSUED	NA Este	P.O. 155 55 0	GERNAFIE PEC:D	enuly EST PEST
S5 Tubing	50236	: ,	1	· •		س		
	50237							
High Temperature Check Yalves	50238	! ,	. ,		ٔ ب	,		1
High Teaperature Manual Globe Yalvus	50239	•	. ,					•
Manual Yalves	50840			_	_	<u> </u>		~
Expansion Joints	50241	·		J	-	•		√
Expansion doints	, 20242	✓	•	,		,		~
Manual 3-Way Valves	50243		. ,	,		v		
Pump Connectors	50244	,		1		,		,
Jiaohragm Pump	50245	-	•	J	•	•		
Automatic Valve	50246	-	•	_	,	1		
Bursting Discs	50247	,	~	•	•	v		1
Check Valves	50248	•	•	J	~	•		1
Autometic Velvé	50249	•	~	,	-	•		•

EQUANENT PROCURERENT STATUS											
EQUIPMENT NO. 6 NAME	P. O. NUMBER	FUNC SPECS 1.5SUED	ING SPECS ISSUED	rfq Issued	ISSUED	P.O. ISSUED	CERTAINTED MEGIO	(5) (5) (6) (6)			
Field Instrumentation	50250	<u> </u>		•		•		•			
Field Instrumentation	50251	,		,	-	-		*			
Field Instrumentation	50252		_	_	-	, 1		~			
Field instrumentation	50253	<u> </u>	-	· •	-	-		/			
Field Instrumentation	50854	<u> </u>	_	_	•	•		/			
Field instrumentation	50255	,		_	<u>.</u>			v			
Field Instrumentation	50256			v	_	٠ ــ		4			
Field Instrumentation	50257	•	•	7	•	w		•			
Field Instrumentation	50258	,		_	,	-		•			
Field Instrumentation	50259	!	-	•	-	•		1			
Field Instrumentation	50260	-	•		•	•		* *			
Field Instrumentation	50261	,	•	·	-	_		•			
Field Instrumentation	50262	•	J	,	J	v		1			
Field Instrumentation	50263		•	•	,	•		•			
Field Instrumentation	50264		•	•	·			V			

EQUIPMENT NO. 6 NAME	P. O. NUMBER	EUNG SPEGS IISSUED	ERG SPEGS ISSUED	REQ ISSUED	rfr !ssufd	P,O, ISSUED	GEPILHFNED DWG Regyd	EDUMP- MENT REGID
Field Instrumentation	50865	•	•	, -	•	•		-
Field Instrumentation	50256	, ,	-	-	_	-		/
Field instrumentation	53267				•	-		· ·
field instrumentation	50268		~	•	v	_		
Field Instrumentation	50269	,	-	V	,	v		5 -
Field instrumentation	50270		•	,	,	-		/
Field Instrumentation	50271			-	•	I		,
Sample Conditioners	56272	•	٠ س	_	-	س		
Level Guage	50273			U.	J	_		1
HC1 Monitor	50274	-	-	•		_		
HC! Monitor	50275	•	-	•	•	-		-
HCl Monitor	50276		-	,		1		
HCl Monitor	50277	-	~	-	,	-		
Thermostat & Finstrip Heater	50278	_	-	-	,	•		
HG1 Monitor	50279		•	-	,	•		

EDUATION PROGUSEMENT STATUS

EQUIPMENT PROGUREMENT STATUS											
EQUIPMENT NO. 6 NAME	P. O. NUMBER	PUNG SPECS 15 SUED	FNG SPECS ISSUED	RFQ ISSUED	AFR ISSUED	P.O. ISSUED	CERTIFIED DMG NEC'D	ECUIP- MENT REGID			
HCl Monitor	50280	-	_	-	-	-					
HC1 Monitor	50281	-	-		-	-					
Main Instrument Panel "A"	50282		•	,	•	v					
Main Instrument Panel "A"	50283	-	-		-						
Main Instrument Panel "A"	50284			,	,	_					
Main Instrument Panel "A"	50285	U	Ų	,		·					
Main Instrument Panel "A"	50286	٠		•	v	•					
Main Instrument Panel "A"	50287		~	•	¥	-					
Main Instrument Panel "A"	50288		,		v	•					
Main Instrument Panel "A"	50289		•	-	•	٠					
Panel "E"	E0 290		,	•	•	-					
Panel "E"	50291		٧	v		•					
Pane} "E"	50292	•	J.	•	,	•					
Panel "E"	50293	v	J		J						
Panel "E"	50294			y	•	1					

	2011		A AUTOR	· · · · · · · · ·			
P. O. NIMBÉR	FUNG SPEGS 1,55UED	ENG SPEGS ISSUED	PFQ 1.SSUED	RFR ISSUED	P.O. ISSUED	CERTAFIED DNG REG'D	EQUIP- PENT REC'D
50295	-	-		-	-		
50296		-	-	-	-		
50297	-	·	-		-		
50298		-	•	•			
50299			,	-	_		
50300			,	,	_		· · · · · · · · · · · · · · · · · · ·
50301	,	•	,	,	•		
50302		>	•	•	_		
50303	•	ر ا	,	v	•		······································
50304			-	~	v		
50305	-	v	,	_	_		
50306	1	,	v	J	,		
50307		· ·		-	-		
50308			-				
50309	-	-	-	•			
	50295 50296 50296 50297 50298 50299 50300 50301 50302 50303 50304 50305 50306	50295	SO SPECS SPECS	SPECS SPECS ISSUED ISSUED	P. O. FUNC SPECS SPECS SPECS SPECS ISSUED ISSUED	P. O. PUNC SPECS SPECS SPECS SPECS ISSUED ISSUED	NIMBER SPECS SPECS SPECS ISSUED ISSU

The second secon	<u>. </u>	ATT THE		NT STATUS				
EQUIPMENT NO. 6 NAME	P. O. NOPRER	FUNC SPECS SSUED	ENG SPECS 155UED	req Lesued	rfr Issuen	P.O. 155UED	CEAN FIEI RECID	
Fame1 "Q"	50310	v	من	٠	•	•		
Panel "Q"	50311	-	~	•	1			
	50312							
Panel "6"	50313	,	١	٠	١	•		
	50314							
	50315							
Plastic Ball Valves	50316	-	-	١	900	ì		1
Lined Plug Valves	50317	_	-	-	-			,
Pressure Indicators	50318	Ļ	-	,	•	•		,
Pressure Guages	50319	V	•	v	•	-		•
Field Instrumentation	50320	•	•	•	v	1		v
Temperature Indicators	50321	٠	,	•	•	•	-1	•
Backflow Prevenser	50322		J	Ų	J	٧		J
SS Pipe	50323	J	y	•	J	•		√
SS Fipe Fittings	56324		~	•	•	,		V

LOUIPHENT PROCUREMENT STATUS											
EQUIPMENT NO. & NAME	NÜ-S ÉA	FUNG SPEGS ISSUED	ENG SPECS ISSUED	rfq Issued	rfr Issuen	P.O. ISSUED	GEREIFIE DWG REC'D	EQUIP MENT REC'D			
Flange Gäsket	50325	سد	_		_	•					
Manual Ball Valves	50328		•		ټ	د		٧			
	80327										
	50328										
Perex Breatners	50329	د	١	١	٧	٦		•			
Inline Filters	50330	•	١	١	•	7		1 -			
Inline Strainers	50331	1	>	•	•	١		1			
	50332							1			
	50333										
Filters	50334	•	~		•	•					
Pipe Fittings	50335	•	•	•	•	٠		•			
Sample Panel "A"	50336	U	-	v	1	1					
	50 337										
Fume Hood	50338	•	٧	~	~	~		1			
SS Pipe Fittings	50 339		•	•	-	•		•			

EQUIPMENT PROGUREMENT STATUS										
EQUIPMENT NO. 6 NAME	P. O. NUMBER	FUNC SPEGS 155UED	ENG SPECS 188UED	rfq 1,8 Sued	AFR 185UED	P.O. 155UED	GERALIANA DING LICEC'D			
	50340									
Vogt Valvé	50341	~	•	~		٠				
Sample Pane'l "A"	50342	v	من	ب	•	•				
	50343									
Sample Panel "A"	50344	•	~	J	٠					
Sample Panel "H"	50345	•	,	١	•	•				
Sample Panel "N" :	50346	v	v	١	V	٥				
Sample Panel "N"	50347	*	,	١	,	•				
Sample Panel "A"	50348	ý	v	v	<u>~</u>	J				
Sample Panel "A"	50349	٠	,		•	-				
Sample Panel "A"	50350	1	-	•	¥	Ü				
	50351									
	50352									
	50353						4)	To the same		
	50354					29				

Edit Mert, Akognyeneki, 21VInz											
EQUIPMENT NO. & NAME	P. O. NUMBER	FUNG SPECS ISSUED	ENG SPECS 155UED	RFQ 15SUED	RFR Issued	P.O. ISSUED	FREC'D	EQUIP- ME NT REC'D			
Xerox Copier Rental	50355			,	1	•					
				·			· · · · · · · · · · · · · · · · · · ·				
						_					
											
											
· · · · · · · · · · · · · · · · · · ·	<u> </u>										
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		<u></u>	<u> </u>			<u> </u>	L				

EQUIPMENT PROCUREMENT STATUS										
EQUIPMENT NO. 4 NAME	P. O. NUMBER	FUNC SPECS 155UED	EI/G SPECS ISSUED	RFQ ISSUED	AFR 155UED	P.O. ISSUED	ERTASTED DMC: DEC'D	EGUI REGUI		
Caged Ladder	24302	~	~	-		-				
Vacuum Rolief Valves	29751	u	v	•	-	1				
Check Valves	32521	~	~	1		-				
Field Instrumentation	33651	~	٠.	٧	1	-		1		
Gasket & O-Rings	33653	v	•		•	-				
Instrument Equipment List	33654	•	-	v	v	1		1		
Plant Emergency Trip System	38094	v	•	v	v	1				
Computer Components ·	38177		~	•	v	ı				
Instrument Equipment List	33655		-		1	~				
Ram Valve Assembly	33656	•		,	١	1				
Ram Valve Assembly	33657	v		٧	1	>				
Detector	33660	٧	•	v	•	٧				
Peristaltic Pump	33661	~	,	v	~	J				
Cartride Tape	33662	~	J	~	~	J		,		
Lab Equipment	33663	U	J	~	Ý	•				

EQUIPMENT PROGUNENT STATUS											
P. O. SUMBER	FUNG SPEGS ISSUED	ENG SPEGS 15SUED	rfq 15sued	RFR ISSUED		Delc	EQUIT WENT REGIL				
32664	J	,	1	,	J		•				
35516	,		,	1	1						
35517		,	7	1	1						
35519	,	,	1	d	,						
35518	,	1	J	✓	1						
33666	,	,	7	1	1		<u> </u>				
33667	,	,	J	√	1						
33679	,		1	1	1						
33681	,	4	>	J	1		· · · · · · · · · · · · · · · · · · ·				
33670	,		1	V	1						
33675		,	J	4	,		<u> </u>				
33672	1	1	,	,	,						
33682	,	-		1							
	<u> </u>						:				
	33664 35516 35517 35519 35518 33666 33667 33679 33679 33670	32664 SPEGS	SUMMER SPECS SPE	SIMPLE SPECS SPE	Number Specs Specs Specs Issued Issu	P. O. SPECS SPECS SPECS ISSUED ISSUE	Number SPECS SPECS SPECS ISSUED ISSU				